



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

October 31, 2025	
IGI Report Number	LG746525149
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	EMERALD CUT
Measurements	9.56 X 7.07 X 4.77 MM

GRADING RESULTS

Carat Weight	3.10 CARATS
Color Grade	F
Clarity Grade	VVS 2

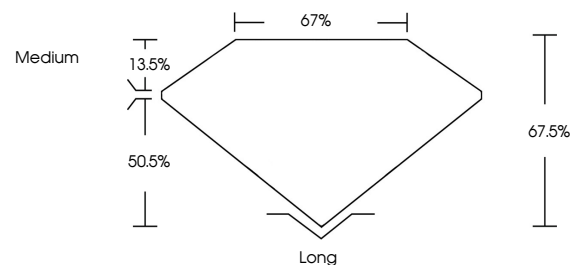
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	15 LG746525149

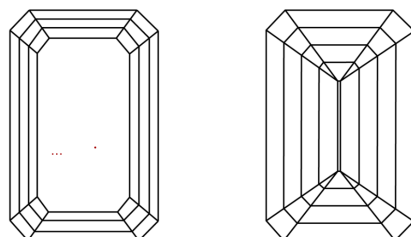
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG746525149
Report verification at igi.org

PROPORTIONS

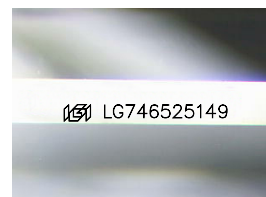


CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

LABORATORY GROWN DIAMOND REPORT



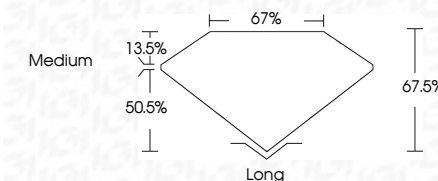
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October 31, 2025
 CGI Report No LG746525149
 EMERALD CIT

3.10 CARATS	VS 2	Long	EXCELLENT
F	67.6%	Medium	EXCELLENT
	67%		NONE
			100% 127462053120

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